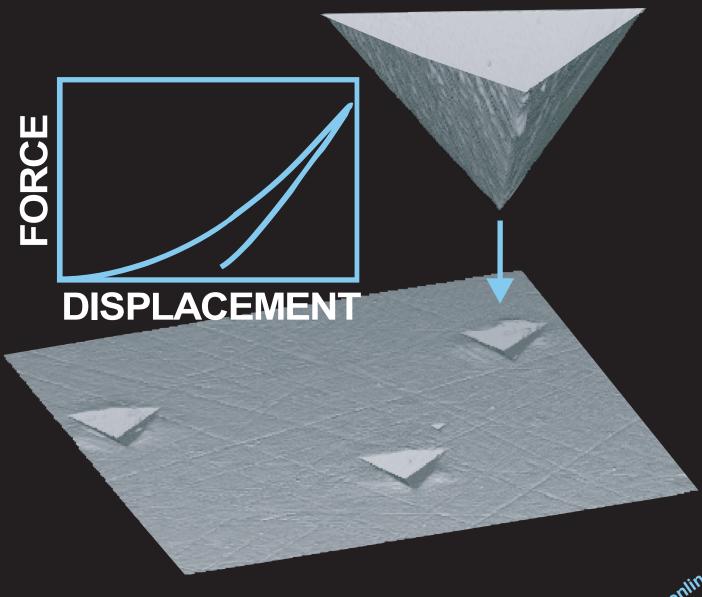
Journal of Research of the

National Institute of Standards and Technology

July - August 2003, Vol. 108, No. 4 ISSN 1044-677X





National Institute of Standards and Technology
Technology Administration, U.S. Department of Commerce

Available online

he National Institute of Standards and Technology was established in 1988 by Congress to "assist industry in the development of technology ... needed to improve product quality, to modernize manufacturing processes, to ensure product reliability ... and to facilitate rapid commercialization ... of products based on new scientific discoveries."

NIST, originally founded as the National Bureau of Standards in 1901, works to strengthen U.S. industry's competitiveness; advance science and engineering; and improve public health, safety, and the environment. One of the agency's basic functions is to develop, maintain, and retain custody of the national standards of measurement, and provide the means and methods for comparing standards used in science, engineering, manufacturing, commerce, industry, and education with the standards adopted or recognized by the Federal Government.

As an agency of the U.S. Commerce Department's Technology Administration, NIST conducts basic and applied research in the physical sciences and engineering, and develops measurement techniques, test methods, standards, and related services. The Institute does generic and precompetitive work on new and advanced technologies. NIST's research facilities are located at Gaithersburg, MD 20899, and at Boulder, CO 80303. Major technical operating units and their principal activities are listed below. For more information visit the NIST Website at http://www.nist.gov, or contact the Publications and Program Inquiries Desk, 301-975-3058.

Office of the Director

- National Quality Program
- · International and Academic Affairs

Technology Services

- Standards Services
- Technology Partnerships
- Measurement Services
- Information Services
- Weights and Measures

Advanced Technology Program

- Economic Assessment
- Information Technology and Applications
- Chemistry and Life Sciences
- · Electronics and Photonics Technology

Manufacturing Extension Partnership Program

- Regional Programs
- National Programs
- Program Development

Electronics and Electrical Engineering Laboratory

- Microelectronics
- Law Enforcement Standards
- Electricity
- Semiconductor Electronics
- Radio-Frequency Technology¹
- Electromagnetic Technology¹
- Optoelectronics¹
- Magnetic Technology¹

Materials Science and Engineering Laboratory

- Intelligent Processing of Materials
- Ceramics
- Materials Reliability¹
- Polymers
- Metallurgy
- NIST Center for Neutron Research

Chemical Science and Technology Laboratory

- Biotechnology
- Process Measurements
- Surface and Microanalysis Science
- Physical and Chemical Properties²
- Analytical Chemistry

Physics Laboratory

- Electron and Optical Physics
- Atomic Physics
- Optical Technology
- Ionizing Radiation
- Time and Frequency¹
- Quantum Physics¹

Manufacturing Engineering Laboratory

- Precision Engineering
- Manufacturing Metrology
- Intelligent Systems
- Fabrication Technology
- Manufacturing Systems Integration

Building and Fire Research Laboratory

- Applied Economics
- · Materials and Construction Research
- Building Environment
- · Fire Research

Information Technology Laboratory

- Mathematical and Computational Sciences²
- Advanced Network Technologies
- Computer Security
- Information Access
- Convergent Information Systems
- Information Services and Computing
- Software Diagnostics and Conformance Testing
- Statistical Engineering

Note to Readers

Dear Reader,

With this issue, we begin a new feature in the *Journal of Research of the National Institute of Standards and Technology*. The article, "Review of Instrumented Indentation," by Mark VanLandingham is the first in a series of Invited Reviews of key research areas at NIST. These review articles are intended primarily for a general technical audience, not only for practitioners in the subjects written about, but also to highlight the diversity and importance of NIST research for a wide audience. Instrumented indentation, for example, as discussed in Mark VanLandingham's leadoff review article, is an important method for studying the mechanical response of materials over a wide range of hardness. Because displacements measured with this technique are typically in the nanometer range, the results are particularly useful for materials applications in Nanotechnology, a field with great technical and economic potential.

The Board of Editors and the staff of the Journal have worked with the Laboratory Directors and their staffs to develop an initial series of topics that shows the diversity of NIST research activities. We are looking forward to review articles on such topics as radioactive carbon dating, international arrangements for comparing national measurement standards, and NIST research related to the automotive industry. If anyone has suggestions for additional topics for featured reviews, please feel free to contact me (email: tvtv@nist.gov) or another member of the Board of Editors. We hope to hear from you.

Theodore VorburgerChief Editor

Cover: The cover illustration is a collage showing a 3-dimensional atomic force microscopy (AFM) image of a ample surface with permanent deformations (below), an AFM image of the indentation probe tip used in the dentation measurements (above right), and the resulting force-displacement curve recorded from one of the neasurements. For more information regarding instrumented indentation, please see the article "Review of instrumented Indentation" by Mark R. VanLandingham on page 249 of this issue. Cover arranged by C. Carey. The Journal of Research of the National Institute of Standards and Technology, the flagship periodic publication of the national metrology institute of the United States, features advances in metrology and related fields of effect the scientific and technical programs of the Institute. The Journal publishes papers on instrumentation for haking accurate measurements, mathematical models of physical phenomena, including computational models, riciaed data, calibration technical, swell-arracterized reference materials, and quality assurance programs that eport the results of current NIST work in these areas. Occasionally, a Special Issue of the Journal is devoted to apers on a single topic. Also appearing on occasion are review articles and reports on conferences and workshops ponsored in whole or in part by NIST. SSSN 1044-677X Coden: JRITEF Library of Congress Catalog Card No.: 89-656121	United States Government	ment Printing Office, Washing	gton: 2003
ample surface with permanent deformations (below), an AFM image of the indentation probe tip used in the indentation measurements (above right), and the resulting force-displacement curve recorded from one of the neasurements. For more information regarding instrumented indentation, please see the article "Review of instrumented Indentation" by Mark R. VanLandingham on page 249 of this issue. Cover arranged by C. Carey. The Journal of Research of the National Institute of Standards and Technology, the flagship periodic publication of the national metrology institute of the United States, features advances in metrology and related fields of hysical science, engineering, applied mathematics, statistics, biotechnology, and information technology that effect the scientific and technical programs of the Institute. The Journal publishes papers on instrumentation for naking accurate measurements, mathematical models of physical phenomena, including computational models, ritical data, calibration techniques, well-characterized reference materials, and quality assurance programs that eport the results of current NIST work in these areas. Occasionally, a Special Issue of the Journal is devoted to apers on a single topic. Also appearing on occasion are review articles and reports on conferences and workshops	ISSN 1044-677X	Coden: JRITEF	Library of Congress Catalog Card No.: 89-656121
ample surface with permanent deformations (below), an AFM image of the indentation probe tip used in the indentation measurements (above right), and the resulting force-displacement curve recorded from one of the neasurements. For more information regarding instrumented indentation, please see the article "Review of	of the national metro physical science, eng- reflect the scientific at making accurate meas critical data, calibration report the results of cu- papers on a single topi	logy institute of the United Sineering, applied mathematic and technical programs of the Isurements, mathematical modern techniques, well-characteristrent NIST work in these are c. Also appearing on occasion	States, features advances in metrology and related fields of s, statistics, biotechnology, and information technology that institute. The <i>Journal</i> publishes papers on instrumentation for els of physical phenomena, including computational models, zed reference materials, and quality assurance programs that has. Occasionally, a Special Issue of the <i>Journal</i> is devoted to
	sample surface with pundentation measurements. For m	permanent deformations (belowents (above right), and the rapport information regarding in	ow), an AFM image of the indentation probe tip used in the esulting force-displacement curve recorded from one of the instrumented indentation, please see the article "Review of

Journal of Research of the National Institute of Standards and Technology

Volume 108 Number 4 July–August 2003

Board of Editors

Available online
http://www.nist.gov/jres

Theodore V. Vorburger Chief Editor

Belinda L. Collins, Technology Services

James K. Olthoff, Electronics and Electrical Engineering Laboratory

Craig M. Shakarji, Manufacturing Engineering Laboratory

Cynthia J. Zeissler, Chemical Science and Technology Laboratory

Ronald Collé, Physics Laboratory

Cynthia K. Montgomery, Materials Science and Engineering Laboratory

Nicos S. Martys, Building and Fire Research Laboratory

Alan H. Goldfine, Information Technology Laboratory

Walter S. Liggett, Jr., Information Technology Laboratory

Clifton M. Carey, Paffenbarger Research Center

Barry N. Taylor, Chief Editor Emeritus

Julian M. Ives

Managing Editor, and Technical Production Editor

Ilse E. Putman, Karen J. Wick

Electronic Composition



U.S. Department of Commerce—Donald L. Evans, Secretary
Technology Administration—Phillip J. Bond, Under Secretary of Commerce for Technology
National Institute of Standards and Technology—Arden L. Bement, Jr., Director



Available online http://www.nist.gov/jres

Note to Readers

Articles

Invited Review		
Review of Instrumented Indentation	Mark R. VanLandingham	249
Towards High Accuracy Reflectometry for Extreme-Ultraviolet Lithography	Charles Tarrio, Steven Grantham, Matthew B. Squires, Robert E. Vest, and Thomas B. Lucatorto	267
Virtual Environment for Manipulating Microscopic Particles With Optical Tweezers	Yong-Gu Lee, Kevin W. Lyons, and Thomas W. LeBrun	275
On the Stability of Exponential Backoff	Nah-Oak Song, Byung-Jae Kwak, and Leonard E. Miller	289
A Link-Level Simulator of the cdma2000 Reverse-Link Physical Layer	H. Gharavi, F. Chin, K. Ban, and R. Wyatt-Millington	299

News Briefs

Biomaterial

news Driejs			
GENERAL DEVELOPMENTS	323		
NIST-Developed Wideband Sampling Voltmeter Provides Increased Accuracy to Calibration Laboratory Customers			
Simplified Approach to Calculating Global Warming Potentials Developed			
Research Progresses Toward Critical Molecular Electronics Measurements	324		
NIST/SEMATECH Collaboration Leads to Breakthrough on Interface State Density Extraction			
Optimal Vector-Network-Analyzer Calibration Algorithm Developed by NIST Staff			
NIST Researchers Demonstrate 120-Element Focal-Plane Array for Concealed Weapons Detection	325		
Source of Decoherence in Josephson Qubits Identified by NIST Researchers			
NIST Researchers Develop Microcalorimeter Arrays Using Surface Micromachining			
NIST Researchers Measure the Single Electron Spectrum of InAs Quantum Dots	326		
NIST Researchers Develop New Microwave Characterization Tools for Thin Film Circuits			
Phase Sensitive Neutron Reflectrometry Describes the Structure of a Membrane-Mimetic			

Volume 108, Number 4, July-August 2003 Journal of Research of the National Institute of Standards and Technology

Publication Available on Korea's Standards and Conformity Assessment System Measurements Completed for 20 RM 8240 Standard Bullets	327
AFM Probe Developed for M ³	328
NIST Security Specialists Publish Role-Based Access Control Book	
NIST Collaborates on Study of Adaptive Characterization of Jitter Noise	
in Sampled High-Speed Signals	
NIST Studies Extending the Scope of Electron-Beam Tomography	
Single Atoms Delivered on Demand	329
Scientists Study Whirlpools in Fermion Superfluids	
Data Available on Atomic Spectral Tables for the Chandra X-Ray Observatory	
Handbook of Basic Atomic Spectroscopic Data Available Online	330
NIST Releases Natural Ventilation Design and Analysis Tool	
First Principles Calculations of Pb and O Vacancies in Perovskite Compounds Performed	
NIST Hosts Workshop on Language Recognition	331
NCNR's User-Friendly Rietveld Software has Wide Impact on Structure Analysis	
Phase Equilibria Data for Electronic Ceramics Published	332
NIST Writes First MEMS Standards	
Researchers Use New Method for In Situ Tip Regeneration in Vacuum	
Sensitive Microsensors Recognize Chemical Warfare Agents	333
NIST Develops High-Resolution Technique for Characterization of	
Nanoscale Patterns With Small Angle X-Ray Scattering	
Overview of the U.S. Approach to Standards, Conformity Assessment,	334
and Metrology Available	
STANDARD REFERENCE MATERIALS	334
NIST Develops a Standard Reference Material for Peanut Butter	
NIST Plays Role in Keeping Tin Cans Lead-Free	